

JOIN THE CUTTING-EDGE MEMS TECHNOLOGY TRAINING PROGRAM!



Seize the opportunity to get trained and train others on MEMS technology through an exciting new initiative by the IEEE Sensors Council (IEEE SC) in collaboration with the Institute of Smart Structures and Systems (ISSS).

We are looking to train early career researchers on MEMS MPW runs. This training program will give you an opportunity to gain global visibility by engaging with SC chapters and conducting training. If you want to apply, please submit your application by 10 August 2024.

APPLICATION DETAILS:

Deadline: Apply by ~~August 10~~, 2024 September 10th

Application Form: <https://forms.gle/HPmpZr8nsKEC3MPk8>

ELIGIBILITY CRITERIA:

1. Basic knowledge of semiconductor fabrication
2. Familiarity with FEM-based Multiphysics tools
3. Access to any Multiphysics software
4. Commitment of 1 to 1.5 years to this initiative

TRAINING PROVIDED BY:

- » Prof. Ananthasuresh, Indian Institute of Science, Bengaluru, India
- » Dr. Jeronimo Segovia, Texas Instruments Kilby Labs, USA
- » Dr. Sambuddha Khan, Tyndall National Institute, Ireland
- » Dr. Sudhanshu Sekhar, Indian Institute of Science, Bengaluru, India
- » Dr. Veda Sandeep Nagaraja, Tyndall National Institute, Ireland

For more details, contact Dr. Veda Sandeep Nagaraja (Veda.sandeep@tyndall.ie), Sensors Council Chapter Engagement Committee Chair, and VP ISSS.

JOIN US AND BE AT THE FOREFRONT OF MEMS TECHNOLOGY!